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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of

APPROPRIATELY FILED FEB 2006

Mineo HIRAMATSU and Masaru HORI

Serial No.: Not Yet Assigned Group Art Unit: Not Yet Assigned

Filing Date: Concurrently Herewith Examiner: Not Yet Assigned

For: METHOD FOR PRODUCING CARBON NANOWALLS, CARBON
NANOWALL, AND APPARATUS FOR PRODUCING CARBON
NANOWALLS

Honorable Commissioner of Patents
Alexandria, Virginia 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

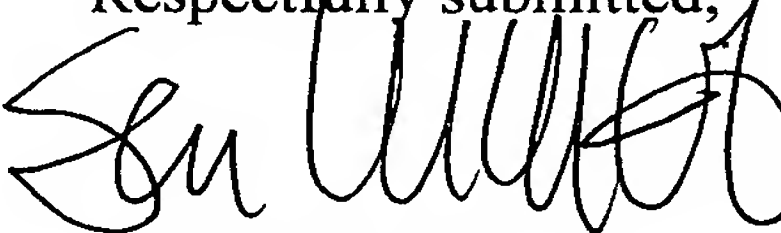
Under the provisions of 37 CFR §1.97 through §1.98 and pursuant to applicant's duty of disclosure under 37 CFR §1.56, applicants respectfully bring the following documents listed on the attached form PTO-1449 and cited in the International Search Report (PCT Form PCT/ISA/210) in the International application, to the attention of the Examiner in charge of the above-identified application. Copies of the listed documents are provided herewith for the convenience of the Examiner. In compliance with the concise explanation requirement under 37 CFR §1.98(a)(3) for foreign language documents, the relevance of some of these documents is discussed on page 2 of the subject application, and English-language Abstracts are attached to the references.

This citation does not constitute an admission that the references are relevant or material to the claims. They are only cited as constituting related art of which applicants are aware.

It is respectfully requested that the listed references be considered by the Examiner and formally made of record in this application.

Please charge any deficiencies in fees and credit any overpayment of fees to Attorney's Deposit Account No. 50-0481.

Date: 2/24/06
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Respectfully submitted,

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INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i>	Docket Number (Optional) F06-436-US	Application Number Not Yet Assigned
	Applicant(s) Mineo HIRAMATSU and Masaru HORI	
	Filing Date Concurrently Herewith	Group Art Unit Not Yet Assigned

U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

U.S. PATENT APPLICATION PUBLICATIONS							
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS								
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
		11-67490	03/09/1999	Japan			YES	NO
		2003-173980	06/26/2003	Japan			ABS	
		2001-81570	03/27/2001	Japan			ABS	

OTHER DOCUMENTS			(Including Author, Title, Date, Pertinent Pages, Etc.)
		Mineo HIRAMATSU, et al., "Fabrication of Carbon Nanowalls Using RF Plasma CVD" Abstracts for The 16th Symposium on Plasma Science for Materials, pp. 20, A2-4.	
		Mineo HIRAMATSU, et al., "Fabrication of vertically aligned carbon nanowalls using capacitively coupled plasma-enhanced chemical vapor deposition assisted by hydrogen radical injection", Applied Physics Letters, Vol. 84, No. 23, pp. 4708-4710 (2004).	

EXAMINER	DATE CONSIDERED
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.